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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Yasuji HIRAMATSU, et al.

SERIAL NO.: NEW U.S. PCT APPLICATION

FILED: HERewith

INTERNATIONAL APPLICATION NO.: PCT/JP01/06287

INTERNATIONAL FILING DATE: July 19, 2001

FOR: CERAMIC HEATER FOR A SEMICONDUCTOR PRODUCING/EXAMINING DEVICE,
PROCESS OF PRODUCING THE CERAMIC HEATER, AND PRODUCTION SYSTEM OF THE
CERAMIC HEATER**REQUEST FOR PRIORITY UNDER 35 U.S.C. 119**
AND THE INTERNATIONAL CONVENTIONAssistant Commissioner for Patents
Washington, D.C. 20231*Yasuji*
#5
3/5/2003

Sir:

In the matter of the above-identified application for patent, notice is hereby given that
the applicant claims as priority:**COUNTRY**
Japan**APPLICATION NO**
2000-219671**DAY/MONTH/YEAR**
19 July 2000Certified copies of the corresponding Convention application(s) were submitted to the
International Bureau in PCT Application No. PCT/JP01/06287. Receipt of the certified
copy(s) by the International Bureau in a timely manner under PCT Rule 17.1(a) has been
acknowledged as evidenced by the attached PCT/IB/304.Respectfully submitted,
OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

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